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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Thomas Hecht et al.

Examiner: Unknown

Serial No.: 10/529,412

Group Art Unit: 1762

Filed: December 21, 2006

Docket No.: I433.153.101/13.555

Title: METHOD AND PROCESS REACTOR FOR SEQUENTIAL GAS PHASE DEPOSITION BY MEANS OF A PROCESS CHAMBER AND AN AUXILIARY CHAMBER

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

We are transmitting herewith the attached:

- ☒ Transmittal Sheet containing Certificate of Mailing under 37 C.F.R. 1.8
- ☒ Supplemental Information Disclosure Statement 2 pg(s).
- ☒ Form PTO-1449 1 pg(s).
- ☒ Copy of 2 cited references
- ☐ The Commissioner is authorized to charge \$0.00 to Deposit Account No. 500471 to cover the required fee.
- ☐ Other: \_\_\_\_\_
- ☒ Return Postcard

Customer No. 025281

By

Name: Paul P. Kempf (Reg. No. 39,727)

Please consider this a Petition for Extension of Time for a sufficient number of months to enter these papers, if appropriate. At any time during the pendency of this application, please change any additional fees or credit overpayment to Deposit Account No. 500471.

### CERTIFICATE UNDER 37 C.F.R. 1.8:

Date of Deposit: 03/05/07

The undersigned hereby certifies that this paper or papers, as described herein, are being deposited in the United States Postal Service as First Class Mail, addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Name: Paul P. Kempf



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant:	Thomas Hecht et al.	Examiner:	Unassigned
Serial No.:	10/529,412	Group Art Unit:	1762
Filed:	December 21, 2006	Docket:	I433.153.101/13.555
Title:	METHOD AND PROCESS REACTOR FOR SEQUENTIAL GAS PHASE DEPOSITION BY MEANS OF A PROCESS CHAMBER AND AN AUXILARY CHAMBER		

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**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Dear Sir/Madam:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached form 1449 be considered by the Examiner and made of record. The cited references are enclosed for the Examiner's review. Pursuant to the provisions of M.P.E.P. 609, Applicants further request a copy of the 1449 form, marked as being considered and initialled by the Examiner, be returned with the next Official Communication.

Since this Supplemental Information Disclosure Statement is being submitted within three months of filing national application; or date of entry of national application; or before the mailing date of the first Office Action on the merits, a fee has not been enclosed. However, if such fee is required, the Patent Office is hereby authorized to charge Deposit Account No. 500471 for fees as set forth under 37 C.F.R. 1.17(p).

**Supplemental Information Disclosure Statement**

Applicant: Thomas Hecht et al.

Serial No.: 10/529,412

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Applicants respectfully request consideration of these references during prosecution of the above-identified matter. The Examiner is invited to contact the Applicants' representative at the below-listed telephone number if there are any questions regarding this Communication or the tendered references.

Respectfully submitted,

Thomas Hecht et al.

By their attorneys,

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100 South Fifth Street

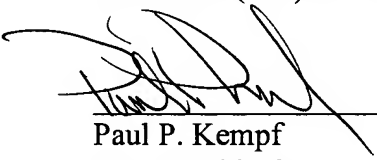
Minneapolis, MN 55402

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Dated: 03/05/07

PPK/mlm

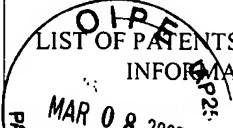
  
Paul P. Kempf

Reg. No. 39,727

**CERTIFICATE UNDER 37 C.F.R. 1.8:** The undersigned hereby certifies that this paper or papers, as described herein, are being deposited in the United States Postal Service, as first class mail, in an envelope address to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 5<sup>th</sup> day of March, 2007.

By 

Name: Paul P. Kempf

FORM PTO-1449		Docket No.: I433.153.101/13.555	Serial No.: 10/529,412
 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT		Applicant: Thomas Hecht et al.	
		Filing Date: December 21, 2006	Group Art: 1762

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
AA						
AB						
AC						
AD						
AE						
AF						
AG						
AH						
AI						
AJ						
AK						
AL						

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Class	Sub Class	Translated Yes No
AM	1 446 262	03/05/1970	Germany			Yes (Abstract)
AN	44 01 718	08/18/1995	Germany			Yes (Abstract)
AO						Yes

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	
AS	
AT	

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.